

<b>Notice of References Cited</b>	Application/Control No. 10/607,184	Applicant(s)/Patent Under Reexamination PATTON ET AL	
	Examiner Brian Q. Le	Art Unit 2623	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 97/25177	07-1997	US	Kaplan et al.	N/A
	O	WO 00/68870	05-2000	US	Regev, Eyal et al.	N/A
	P					
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	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Igor I. Smolyanivo et al. "Micromachining of diamond with a near-field scanning optical microscope", Optics Letters October 1, 2001 Vol. 26, No. 19, 2001.
	V	
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	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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